;	Se	are	rch Notes					

	Application/Control No.	Applicant(s)/Patent under Reexamination
İ	10/676,658	LIN, ZHENHAI
	Examiner	Art Unit
	Dennis L. Vautrot	2167

	SEARCHED			
Class	Subclass	Date	Examiner	
707	1-100	7/25/2006	DV	

INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	
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SEARCH N)
	DATE	EXMR
EAST (updated search form 7/25/2006)	1/26/2007	DV
Inventor Name Search	7/25/2006	DV
ACM Portal	7/27/2006	DV
EBSCO	7/26/2006	DV
IEEE Explore	7/26/2006	DV
Google Patents	1/23/2007	DV